INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

January 10, 2026

IGI Report Number	LG763622544
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	7.74 X 7.74 X 4.91 MM

GRADING RESULTS

Carat Weight	2.58 CARATS
Color Grade	E
Clarity Grade	VS 1

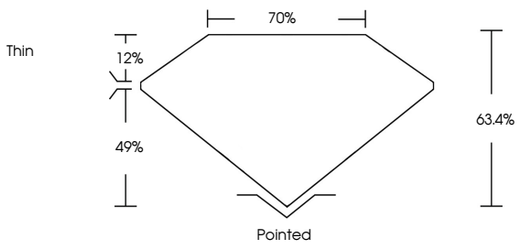
ADDITIONAL GRADING INFORMATION

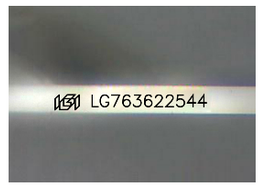
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG763622544

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG763622544
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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www.igi.org

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Thin 70% 12% 49% 63.4% Pointed

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IGI

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SQUARE EMERALD CUT
7.74 X 7.74 X 4.91 MM
Carat Weight 2.58 CARATS
Color Grade E
Clarity Grade VS 1
Depth 63.4%
Table 70%
Girdle Thin
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG763622544
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa